Page 1

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	Time Stamp	2006/05/24 15:08	2004/09/24 09:24	2004/09/24 09:25	2004/09/24 10:04
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EAS I Search History	Search Query	(Polishing adj pad with (polyurethane polyolefin polyurethane polyolefin polyuryalochol polywinyalocate polycarybrande polyednylene polyaryylene polyethylene polysther polyether polyamide polysther polyamide polymide polytetraflurocethylene polyetheretherketene) and ("poisson's" adj ratio)	(Polishing adj pad with (polyurethanes polyolefins polywinyladorhols polywinyladetates polycarbonates (polyacrylic adj acids) polyacrylamides polyethylenes polypropylenes nylons fluorocarbons polyesters polytetrafluoroethylenes polytetrafluoroethylenes polytetrafluoroethylenes polytetrafluoroethylenes polytetrafluoroethylenes polytetrafluoroethylenes polytetrafluoroethylenes polytetrafluoroethylenes	("poisson's" adj ratio) with negative	(US-6517417-\$ or US-6648733-\$ or US-664171-\$ or US-66705934-\$ or US-6705934-\$ or US-6095024-\$ or US-617181-\$ or US-6099504-\$ or US-607778-\$ or US-6387312-\$ or US-6045716-\$). did or (US-20030220061-\$ or US-2003003857-\$ or US-20020197935-\$ or US-20020197935-\$ or US-2002016111-\$ or US-20030216111-\$ or US-20010024940-\$ or US-20010024940-\$ or US-20010024940-\$ or US-20010024940-\$ or US-20010021611-\$ or US-20010021610-\$ or US-200200216110-\$ or US-200200216110-\$ or US-200200216110-\$ or US-200200216110-\$ or US-200200216110-\$ or US-200200216110-\$ or US-20020021610-\$ or US-20020021610-\$ or US-200200216110-\$ or
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ic popula.	USPAT; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT
\$ 6628099 31 ~ \$ 2102139 311/	or US-661471-\$ or US-670394-\$ or US-6695902-\$ or US-670394-\$ or US-6095902-\$ or US-6171181-\$ or US-6095902-\$ or US-6171181-\$ or US-637312-\$ or US-6045716-\$), or US-20030020061-\$ or US-2003003857-\$ or US-2002007935-\$ or US-20020077036-\$ or US-20020077036-\$ or US-2002007404-\$ or US-20010024940-\$ or US-20010024940-\$ or US-20010024940-\$ or	(Polishing adj pad with (polyurethanes polyolefins polyvinylacetates polyvinylacetates polycarbonates (polyacylic adj acids) polyacylamides polyethylenes polyampylenes nylons fluorocarbons polyesters polyamides polytetrafluoroethylenes polyethere polyamides polytetrafluoroethylenes polyetheretherketones)) and density	Polishing adj pad with (polyurethanes polyolefins polyvinylaciotos polyvinylaciates polycarbonates (polyacylic adj acids) polyacylamides polyethylenes polypropylenes nylons fluorocarbons polyesters polytethers polyamides polymides polytethers polyamides polymides polytetherspluorocatylylenes polytetherstluorocatylylenes	"poisson's" adj ratio	(("4,668,557" or "4,688,557" or "5,196,353" or "5,284,435" or "5,314,512" or "5,391,516" or "5,433,651" or "5,439,641" or "5,609,511" or "5,643,046" or "5,609,511" or "5,643,046" or "5,609,407" or "5,893,796" or "5,949,927" or "5,893,796" or "5,949,927" or "5,893,796" or "6,949,927" or "6,203,407" or "6,454,634",0,1 and ("poisson)s" and "poisson"s" and "poisson s" and "
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US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT
(("4,668,557" or "4,688,557" or "5, 1196,352" or "5,284,315" or "5,314, 512" or "5,391,516" or "5,433,651" or "5,489,231" or "5,609,511" or "5, 643,046" or "5,638,183" or "5,739, 642" or "5,838,447" or "5,872,633" or "5,833,796" or "5,949,927" or "5, 564,379" or "6,662,968" or "6,126, 532" or "6,103,407" or "6,454, 634").pn.) not (Polishing adj pad with (polyurethanes polyolefins polyurityalcohos polyvinyacetates polyorityalcohos polyvinyacetates polyorityalcohos polyvinyacetates polyorityalcohos polyvinyacetates polyethylenes polyparogylenes mydons fluoroachon polyesters polyethylenes polyparogylenes polyethylenes polyparogylenes polyethylenes polyparogylenes polyethylenes polyparogylenes	(Polishing adj pad) and (("4,668, 557" or "5, 196,333" or "5,284,435" or "5,134,512" or "5, 391,516" or "5, 435,651" or "5, 489, 233" or "5,609,511" or "5,649,046" or "5,658,183" or "5,739,642" or "5, 882,442" or "5, 892,633" or "5,964,643" or "6,062,968" or "6,126,352" or "6,002,968" or "6,424,634"),pn.)	Polishing adj pad with (polyurethanes polyolefins polyuryathanes polyolefins polycarbonates (polyacytic adj acids) polyacylamides polyethylenes polypropylenes rylons fluorocathons polyesters polyethers polyamides polymides polytetrafluoroethylenes polytetrafluoroethylenes
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US-PCPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT: EPO; JPO; DERWENT
((Polishing adj pad with (polyurethane pokyolefin polyvinylaochale polyvinylaochale polyvinylaochale polyvinylaochale polyaorylanide polyethylene polypropylene nylon fluorocarbon polyeste polyether polyamide polyether polyamide polyether polyamide polyether polyether polyamide polyether polyvinylacothols polyvinylacothols polyvinylacothols polyvinylacothols polyvinylacothols polyvinylacothols polyvinylacothols polyvinylacothols polyvinylacothols polyethers polyamides polyethers polyamides polyethers polyamides polyethers polyamides polyethers polyamides polyethers polyamides polyether polyethere polyetheres polyamides polyetheretheretheretheres))) and (strain and ((bulk or ("Young's") or shear) adj modulus))	((Polishing adj pad with (polyurethane polyolefin polyurytalachol polyvinydacetate polyarbarbare (polyarytic adj acid) polyarytamide polyethylene polypropylene nylon fluorocarbon polyser polyamide polytether polyamide polytether polyamide polyimide polytether polyamide polyimide polytether polyamide polyimide polytether polyamide polyimide polyurytalochols polyvinyalochols polyvinyalochols polyvinyalochols polyarylic adj acids) polyarytamides polyvinyalochols polyarylic adj acids) polyarytamides polywinides polytether polyetheres polyamides polytetheres polyamides polytetherethere polyamides polytetheretheretheretheres) and ((strain and ((fulk or ("Young's") or shear or elastic) adj modulus))
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2004/10/04 10:03	2004/10/04 10:06
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US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT
((Polishing adj pad with (polyurethane polyolefin polyvinyladoral polyvinyladoral polyvinyladoral polyvinyladoral polycarcylamide polycarcylamide polycarcylamide polypropylene nylon fluorocarbon polypropylene nylon fluorocarbon polyester polyether polyether polyamide polymide polymida polymide polymida polymida polymida polymida polymida polymida polymide polyether polymide polyether polyamide polymides polyether polymide spolyether polymide (strain or modulus)) and (strain or modulus)	((Polishing adj pad with (tokyurethane polyorinylacotale polychinylacotale polychinylacotale polychinylacotale polychinylacotale polychonylene mylon fluorocarbon polypropylene mylon fluorocarbon polycester polyether polyamide polymide polymides polyethers polymides polyetheretheretherethoss))) and (strain or ((tulk or ("Young's") or shear) adj modulus))
250	115
516	S17

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20.01 20,012		2004/10/04 14:28	2004/10/04 15:05	2004/10/04 15:50	2004/10/04 15:06	2004/10/04 15:06	2004/10/04 15:13
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9	USPAT; USPAT; EPO; JPO; DERWENT	us-pgpub; uspat; epo; jpo; derwent	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT
<u> </u>	(Chokurethane polyolefin polyvinylalothol polyvinylalothol polyvinylaoctate polyorarbonate (Chokarylic adj adid) polycarbonate (Chokarylic adj adid) polycarbonate (Chokarylic adj adid) polyorarbonate (Chokaryliche polymide polytetrafluoroethylene polymide polymide polytetrafluoroethylene polymide polymide polymide polymide di pad with (polyurethanes polyolefins polyvinylalothols polyvinylaoctates polyvinylaoctates polyvinylaoctates polyvinylaoctates polymides polypropylenes nylons fluorocarbons polyetters polymides polypetrafluoroethylenes polymotylenes polyetters polymides polyetters polymides polyetters polymides polyetters polymides polyetters polyetters)) and (modulus)	("4,668,557" or "4,688,557" or "5,114, 196,353" or "5,284,435" or "5,314, 512" or "5,391,516" or "5,433,651" or "5,899,233" or "5,609,511" or "5, 643,046" or "5,658,183" or "5,739, 642" or "5,838,447" or "5,872,633" or "5,833,736" or "5,949,927" or "5, 964,643" or "6,062,968" or "6,126, 532" or "6,203,407" or "6,454,	(Polishing adj pad with ((void adj voume) or (pore adj (density or diameter)) or grooves))	(Polishing adj pad with (void adj voume))	(Polishirig adj pad with groove\$)	(Polishing adj pad with (pore adj (density or diameter)))	(Polishing adj pad with (linear adj groove\$))
9	8	4		0	912	13	6
95		819	250	221	225	823	524

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US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT
(Polishing adj pad with (void adj volume))	((Polishing adj pad with (pore adj (density or diameter)))) and ((Polishing adj pad with (void adj volume)))	(((Polishing adj pad with (pohyurethane polyolefin pohyinrylacoho pohyinrylacetate polyacarbonate (polyacrylia adj acid) pohyacytamide polyethylane polyacytamide polyethylane polyacytamide polyethylane polyacytamide polyethylane polyacytamide polyetheretherketone)) or (Polishing adj pad with (polyurethylanes polyacytamides polyacytamide polyacytamides polyactytenes polyacytamides polyactytenes poly	Elastollan C-64D
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US-PGPUB; USPAT; EPO; JPO; DERWENT	USPAT	USPAT	USPAT	US-PGPUB; USPAT; EPO; JPO; DĘRWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT;					
"Elastollan C-64D"	Elastollan and "C-64D"	Elastollan	Elastollan and (polishing adj pad)	(Polishing adj pad with (in adj situ)	(Polishing adj pad with (in adj situ)) and (transparent lense transmissive optic\$ plug)	"20020182866".URPN.	"20020182866".URPN.	"20020182866".URPN.	"6095902".pn.	"6126532".pn.	"5893796" pn. and wavelength	"6120353".pn.	"5949927".pn. and pad
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*	\$2	("451".clas.) and ("re-entrant" or auxetic)	US-PGPUB; USPAT; EPO; JPO; DERWENT	ő	OFF	2005/11/29 13:52
£ .	4	(polishing adj pad) and ("re-entrant" or auxetic)	US-PGPUB; USPAT; EPO; JPO; DERWENT	R	OFF	2005/11/29 13:56
§	\$	auxetic	US-PGPUB; USPAT; EPO; JPO; DERWENT	æ	OFF	2005/11/29 13:56
75	2034	Polishing adj pad with (polyurethane polyolefin polyariyaliochlo polyvinylacetate polyariocate (polyacytic adj acid) polyacytamide polyethylene polypropylene nylon fluorocarbon polypropylene nylon fluorocarbon polyette polyamide polyimide polyether polyamide polyetheretherketone)	US-PGPUB; USPAT; EPO; JPO; DERWENT	X	OFF	2005/11/29 15:07
8 5	-	10/754390.app.	US-PGPUB; USPAT; EPO; JPO; DERWENT	8	OFF	2006/05/23 15:13
\$5	627	(polishing adj pad) and ((expand\$4 near20 expand\$4) or (contract\$4 near20 contract\$4) or (compres\$6 near20 compres\$6))	US-PGPUB; USPAT; EPO; JPO; DERWENT	æ	OFF	2006/05/24 15:09
220	210	(polishing adj pad) same ((expand\$4 near20 expand\$4) or (contract\$4 near20 contract\$4) or (compres\$6 near20 compres\$6))	US-PGPUB; USPAT; EPO; JPO; DERWENT	æ	OFF	2006/05/24 15:17
S21	11	(polishing adj pad) and Poisson\$4	US-PGPUB; USPAT; EPO; JPO; DERWENT	S.	OFF	2006/05/24 15:37
225	6	(polishing adj pad) and (("anti-rubber" or (anti near rubber)) or dilation\$6 or auxetic\$6)	US-PGPUB; USPAT; EPO; JPO; DERWENT	R	OFF	2006/05/24 15:46
553	57	(CMP "chemical mechanical polishing" "chemical mechanical planarizing") and (("anti-rubber" or (anti near rubber)) or dilation\$6 or auxetic\$6)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR.	OFF	2006/05/24 15:44
2 <u>X</u>	0	(CMP "chemical mechanical polishing" "chemical mechanical planarizing") and (auxetic≴6)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/05/24 15:43
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US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT
(CMP "chemical mechanical polishing" "chemical mechanical planarizing") and (dilation\$6)	(OMP "chemical mechanical polishing" "chemical mechanical planarizing") and ("anti-rubber" or (anti near rubber))	(CMP "chemical mechanical polishing" "chemical mechanical planarizing") and (dilational)	hysteresis and Poisson\$5	hysteresis and Poisson\$5 and negative	SS9 and ((polishing adj pad) CMP "Chemical mechanical polishing" "Chemical mechanical" wafer substrate semiconductor\$4)	S59 and (polishing adj pad)	hysteresis and (Poisson\$5 with negative)	(Poisson\$5 with negative)	(Poisson\$5 near2 negative)	S64 and ((polishing adj pad) CMP "Chemical mechanical polishing" "Chemical mechanical" wafer substrate semiconductor\$4)	("re-entrant" or reentrant or auxetic) and (polishing adj pad)
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SSS	S26	222	828	828	88	75	Se2	98	\$	S9S	9 8

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US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT
("re-entrant" or reentrant or auxetic) and (OMP "chemical mechanical polishing" "chemical mechanical planarizing")	("re-entrant" or auxetic) and (CMP "chemical mechanical polishing" "chemical mechanical planarizing")	(auxetic) and (CMP "chemical mechanical polishing!" "chemical mechanical planarizing")	(("re-entrant" or auxetic) and (CMP "chemical mechanical polishing" "chemical mechanical planarizing")) not ("re-entrant" near6 (trench angle angles trenches))	((negative near2 Poisson\$4) or auxetic or auxetic\$4 or dilational or (anti adj rubber) or "anti-rubbe") with (properties property)	((negative near2 Poisson\$4) or aucetic or aucetic\$4 or dilational or clarit adj rubber) or "anti-rubber") with (properties property advantag\$4)	((negative near? Poisson\$4) or auxetic or auxetic\$4) or auxetic\$7 or auxetic\$4 or dilational or (anti adj rubber) or "anti-rubber") with (polyurethanes polyolefins polyvinylalcothols polyvinylacetates polyorative (polyacrylic adj acids) polyacrylamides polyethylenes polyethylenes polyethers polyacitors polyethers poly	((negative near2 Poisson\$4) or auxetic or auxetic\$4 or dilational or (anti adj rubber) or "anti-rubber") with (polymer)	((negative near2 Poisson\$4) or auxetic or auxetic\$4 or dilational or (anti adj rubber) or "anti-rubber") with (polymer polymers polymeric)	S75 and S72
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292	88	9S	025	172	272	Ę	574	S75	S76

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US-PGPUB; USPAT; EPO; JPO; DERWENT	us-pgpub; uspat; epo; jpo; derwent	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT
(polishing adj pad) same (polymeric adj foam) and strength and (abrasion adj resist\$4) and (tear adj resist\$4)	(polishing adj pad) same (polymeric adj foam) and strength and (abrasion adj resist\$4)	((polishing adj pad) same polymer same foam) and strength and (abrasion adj resist\$4)	((polishing adj pad) same polymer\$2 same foam) and strength and (abrasion adj resist\$4)	(polishing adj pad) and (polymer\$2 same foam) and strength and (abrasion adj resist\$4)	("volumetric compression ratio") and (polishing adj pad)	(volum\$6 near3 compression near3 ratio) and (polishing adj pad)	(polishing adj pad) and (\$polyester\$4 same foam) and strength and (abrasion adj resist\$4)	"4668557";pn.	10/457316.app.	(polyester adj foam) and ((polishing planarizing) adj pad\$1)
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<i>21</i> 2	828	6. S.	88	158	88	88	88	88	88	88

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US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT	US-PGPUB; USPAT; EPO; JPO; DERWENT
((polishing planarizing) adj pad\$1) and ((polyester and (polyurethane\$4 polyplefin\$4)) with foam) and abrasive	((polishing planarizing) adj pad\$1) and ((polyester and (polyurethanes4 polyolefin\$4)) with foam) and abrasive and (CMP "chemical mechanical polishing" "chemical mechanical planarizing")	((polishing planarizing) adj. pad\$1) and (polyester with foam) and ((polyurethane\$4 polyolefin\$4) with foam) and abrasive and (CMP "dhemical mechanical polishing" "dhemical mechanical planarizing")	"6656018";pn.	(polyester adj foam) with · polyurethane	(polyester adj foam) with polyurethane with based	(polyester near4 foam) and ((polishing planarizing) adj pad\$1)	(polyester near4 foam) and ((folishing planarizing) adj pad\$1) and (CMP "demical mechanical polishing" "chemical mechanical planarizing")	(polishing adj pad) and (polymer\$2 same foam) and (abrasion adj resist\$4)	(polishing adj pad) and (polymer\$2 same foam) and (abrasion near resist\$4)
75	45	45	7	308	9	25	17	27	
88	& .			 Z6S	233	\$ \$	S95	965	265

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"4668557".pn.	(polishing adj pad) and ((polyester\$4 polyether\$4) same foam) and (abrasion near resist\$4)	(polishing adj pad) and (polymer\$2 same foam) and (abrasion near resist\$4)	S99 not \$100	E002/46283	W002/46283	(polishing adj pad) same (abrasion near resist\$4)	(polishing adj pad) with (abrasion near resist\$4)
2	38	35	ω	0	***	89	36
88	88	S10 0	S10 1	S10 2	33	S10 4	S10 5